

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: YOUNG HOON PARK, ET AL.) Group Art Unit: NYA
For: METHOD OF DEPOSITING THIN FILM)
USING HAFNIUM COMPOUND) Examiner: NYA
)

CLAIM FOR PRIORITY

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

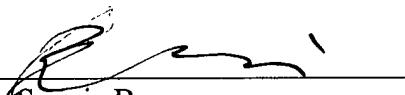
Applicants hereby claim the benefit of the filing date of November 12, 2002 to Korean Application No. 2002-70054 under provisions of 35 U.S.C. 119 and the International Convention for the protection of Industrial Property.

If any fees are due with regard to this claim for priority, please charge them to Deposit Account No. 06-1130 maintained by Applicant's attorneys.

Respectfully submitted,

CANTOR COLBURN LLP

By



Soonja Bae

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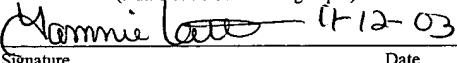
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Date: November 12, 2003

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November 12, 2003 (Date of Deposit)	
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